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PATENT APPLICATION
0038-0358P

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicant:	Keisuke BAN, et al.	Confirmation No.	5452
Application No.:	09/852,267	Group:	1725
Filed:	May 10, 2001	Examiner:	Kuang Y. Lin
For:	METHOD OF CASTING AND CASTING		



RESPONSE TO A RESTRICTION REQUIREMENT

Honorable Commissioner of Patents
and Trademarks
Washington, D. C. 20231

July 11, 2002

Sir:

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JUL 16 2002
TC 1700

In response to the Examiner's Restriction Requirement dated June 12, 2002, the following election and remarks are respectfully submitted in connection with the above-identified application.

IN THE CLAIMS:

Applicants hereby elect Group I consisting of claims 1-10 for initial examination in this application. This election is with traverse.

REMARKS

Applicants thank the Examiner for the thorough consideration given the present application. Claims 1-19 are currently being prosecuted. The Examiner is respectfully